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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	
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Ryohei Higuchi et al.)	Group Art Unit: 2111
)	
Application No.: 10/689,668)	Examiner: MARK H. RINEHART
)	
Filed: October 22, 2003)	Confirmation No.: 6491
)	
For: DATA TRANSFER CONTROL)	
APPARATUS)	
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Information Disclosure Statement ("IDS") is filed in supplement to the IDS filed on November 29, 2005 in the above-identified patent application. Applicant request that the Examiner consider also the attached foreign reference(s) cited on the enclosed PTO/SB/08 in the above-identified patent application.

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§ 1.97 and 1.98.

Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

The documents are being submitted within three (3) months of the filing or entry of the national stage of this application or before the first Office Action on the merits, whichever is later. Since these documents are being filed within the time period set forth in 37 C.F.R. § 1.97(b), no fee or statement is required.

I, the undersigned, hereby state that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to the filing of this Information Disclosure Statement.

I, the undersigned, hereby state that each item of information contained in this Information Disclosure Statement was cited in any communication from a foreign patent office in a counterpart foreign application and that this communication was not received by any individual designated in 37 C.F.R. § 1.56(c) more than thirty (30) days prior to the filing of this Information Disclosure Statement.

This Information Disclosure Statement contains information which is not in the English language but was cited in a search report or other action by a foreign patent office in a counterpart foreign application. In accordance with MPEP § 609 III A(3), an English language version of the search report or action which indicates the degree of relevance found by the foreign office is being submitted herewith.

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

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By:

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

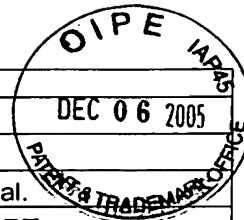
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Complete if Known

Application Number 10/689,668
Filing Date October 22, 2003
First Named Inventor Ryohei Higuchi et al.
Examiner Name MARK H. RINEHART
Attorney Docket Number 027260-680

**U.S. PATENT DOCUMENTS**

Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)
	5,566,350		Yuji Takagi et al.	10/15/1996

FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	STATUS						
					Translation	Partial Translation	Eng. Lang. Summary	Search Report	IPER	Abstract	Cited in Spec

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	Patent Office of the People's Republic of China. Office Action dated October 14, 2005. China Patent Application No. 200410002758.5 filed on January 14, 2004. Renesas Technology Corp. 5 pages.
	Patent Office of the People's Republic of China. Office Action dated October 14, 2005. English Translation. China Patent Application No. 200410002758.5 filed on January 14, 2004. Renesas Technology Corp. 5 pages.

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.